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Docket Number (Optional)

2133.063USU

Application Number  
Not Yet Assigned

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INFORMATION DISCLOSURE CITATION  
IN AN APPLICATION

(Use several sheets if necessary)

Applicant

Leib and Mund

Filing Date

Herewith 13 April 2005

Group Art Unit

2811

Not Yet Assigned

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
A.O.A.	4,374,391	2/15/83	Camlibel et al.	357	17	

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	387175	5/15/65	Switzerland				X

## OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	XP-002251628, Anodic bonding technique under low temperature and low voltage using evaporated glass, Woo-Beom Choi et al., 1997 American Vacuum Society, J. Vac. Sci. Technol. B 15(2)

EXAMINER

a.o.a.

DATE CONSIDERED

6 March 2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.